

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi OKUBO et al.

ATTN: Mail Stop PCT

Application No.: 10/551,136

Docket No.: 125493

Filed: January 5, 2006

For: MASK BLANK, MANUFACTURING METHOD OF MASK BLANK,  
MANUFACTURING METHOD OF TRANSFER MASK AND  
MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE



**NOTIFICATION OF ACCEPTANCE AND FILING RECEIPT STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The above-captioned patent application entered the National Phase on September 29, 2005. The 35 U.S.C. 371 requirements were completed on January 5, 2006.

The original Notification of Acceptance and Filing Receipt have not yet been received. It is respectfully requested that the original Notification of Acceptance and Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,



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Date: June 27, 2006

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